IFW



PATENT Attorney Docket No. 0553-0378

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Shunpei Yamazaki, et al.	 I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Serial No.: 10/664,642	Commissioner for Patents P.O. Box 1450
Filed: September 19, 2003) Alexandria, VA 22313-1450
Examiner: Stanettta D. Isaac) DATE: November 5, 2004) NAME: Christine A. Barglik
Art Unit: 2812) SIGNATURE: Chutture a. Burglik
For: FABRICATION SYSTEM AND	j
MANUFACTURING METHOD OF)
LIGHT EMITTING DEVICE)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT A

Dear Examiner:

We are in receipt of the Office Action dated October 5, 2004, and the following remarks are made in light thereof.